

please enter after final amendment. Thanks DML 9-1-04



AF/2828
FW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jugo Mitomo

Serial No.: 09/934,930

Filed: August 22, 2001

For: SEMICONDUCTOR LASER AND
METHOD OF PRODUCTION THEREOF

Case No.: 9792909-5153

Group Art Unit: 2828

Examiner: Quyen Phan Leung

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 19, 2004.

Enrique Perez

AMENDMENT AFTER FINAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is submitted in response to the Final Office Action mailed May 19, 2004.